**Supporting Information** 

**Distorted Carbon Nitride Structure with Substituted** 

Benzene Moieties for Enhanced Visible Light

**Photocatalytic Activities** 

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Include: Figures S1-S8, Table S1

S-1

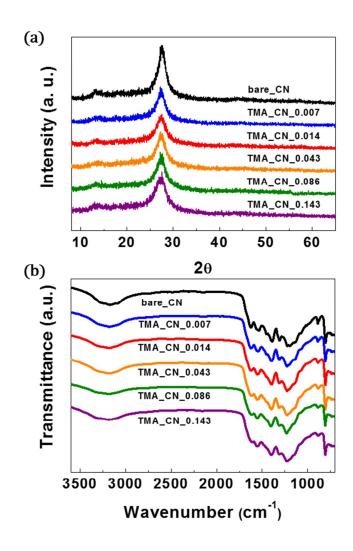
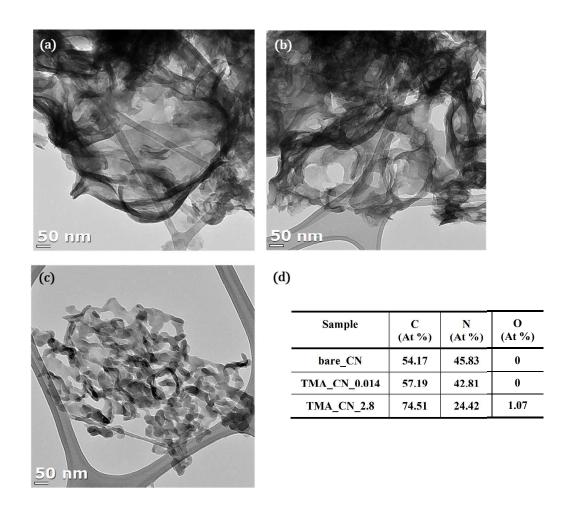


Figure S1. (a) XRD spectra and (b) ATR FT-IR spectra of bare\_CN and TMA\_CN varying content of TMA



**Figure S2.** TEM images of (a) bare\_CN, (b) TMA\_CN\_0.014 and (c) TMA\_CN\_2.8 (d) elemental compositions obtained from EDS analysis

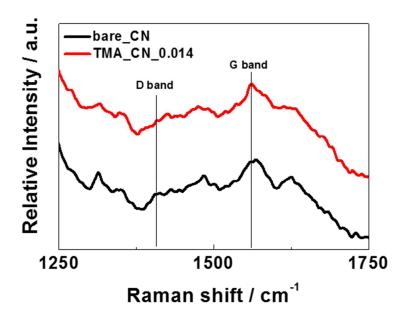
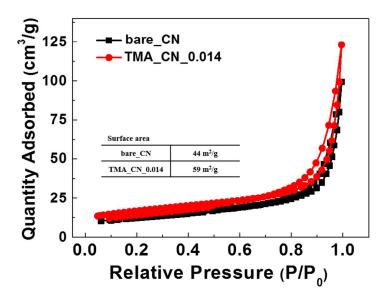
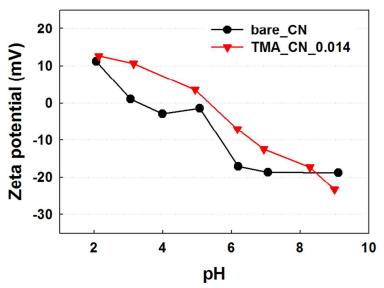


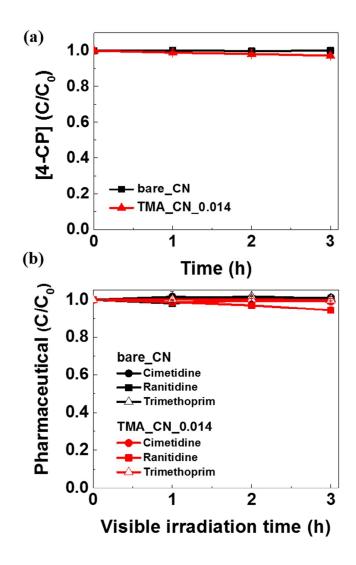
Figure S3. Raman spectra of bare\_CN and TMA\_CN\_0.014



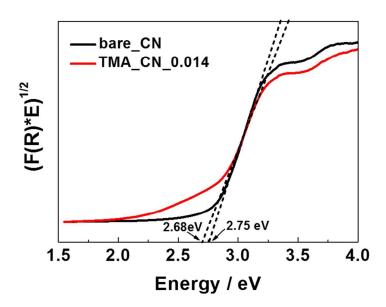
**Figure S4.** The BET surface area analysis of bare\_CN and  $TMA_CN_0.014$  by  $N_2$ -sorption-desorption isotherms



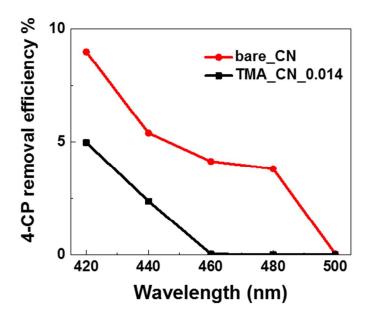
**Figure S5.** Zeta-Potential as a function of pH for bare\_CN and TMA\_CN\_0.014



**Figure S6.** The dark control experiments using bare\_CN and TMA\_CN\_0.014 for the removal of (a) 4-CP and (b) pharmaceutical compounds



**Figure S7.** Tauc plots for bare\_CN and TMA\_CN\_0.014



**Figure S8.** Photocatalytic removal efficiency of 4-CP with bare\_CN and TMA\_CN\_0.014 as a function of monochromatic irradiation wavelength.

	C (wt %)	N (wt %)	H (wt %)	O (wt %)	C/N
bare_CN	33.70	60.55	1.90	1.23	0.556
TMA_CN_0.007	33.59	60.20	1.68	2.08	0.558
TMA_CN_0.014	33.50	59.65	1.71	2.84	0.562
TMA_CN_0.043	33.44	57.98	1.84	3.83	0.577
TMA_CN_0.086	34.10	57.84	1.78	3.84	0.589
TMA_CN_0.143	35.00	56.47	1.80	4.16	0.620

**Table S1.** Elemental analysis of bare\_CN and TMA\_CN\_x.